

INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

Docket Number (Optional)

PD-0436

Application Number

unknown

Applicant(s)

James D. Holker et al.

Filing Date

herewith

Group Art Unit

unknown 3263

1103 U.S. PTO
09/779282
08/08/01

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>h</i>	AA	5,108,819	4/28/92	James W. Heller et al.	428	195	
	AB	5,391,250	2/21/95	Paul S. Cheney, II et al.	156	268	
	AC	5,777,060	7/07/98	William P. Van Antwerp	528	28	
	AD	5,786,439	7/28/98	William P. Van Antwerp et al.	528	77	

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
<i>h</i>	AE	WO 98/56293	12/17/98	PCT				
	AF	WO99/45375	9/10/99	PCT				
	AG	WO 99/45387	9/10/99	PCT				
	AH	WO 99/56613	11/11/99	PCT				

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

6/15/03

EXAMINER: Initial citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

FORM PTO-1449
IREV. 7.801

U.S. Department of Commerce
PATENT AND TRADEMARK OFFICE

Attorney Docket
No.
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INFORMATION DISCLOSURE STATEMENT

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3763

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number							Date	Name	Class	Sub- Class	Filing Date If Appropriate
9	AA	5	1	6	5	4	0	7	11/24/ 92	George S. Wilson et al.	128	635	4/9/91
	AB	5	2	9	9	5	7	1	4/5/94	John J. Mastroto- taro	128	634	1/22/93
	AC	5	3	2	2	0	6	3	6/21/94	Douglas J. Allen et al.	128	635	10/4/91
	AD	5	4	1	1	6	4	7	5/2/95	Kirk W. Johnson et al.	204	153.1	1/25/94
	AE	6	1	0	3	0	3	3	8/15/00	James Say et al.	156	73.1	3/4/98
	AF	6	1	6	2	6	1	1	12/19/ 00	Adam Heller et al.	435	14	1/3/00

FOREIGN PATENT DOCUMENTS

		Document Number							Date	Country	Class	Sub- Class	Translation	
													Yes	No
	AG													

OTHER DOCUMENTS

B	AH	Koudelka, M. et al., "Planar Amperometric Enzyme-Based Glucose Microelectrode", <u>Sensors and Actuators</u> , 18 (Elsevier Sequoia, The Netherlands - 1989), pp. 157-165
	AI	Koudelka, M. et al., "In-vivo Behaviour of Hypodermically Implanted Microfabricated Glucose Sensors", <u>Biosensors & Bioelectronics</u> 6 (Elsevier Science Publishers Ltd., England - 1991), pp. 31-36
	AJ	Mastrototaro, John M. et al., "An electroenzymatic glucose sensor fabricated on a flexible substrate", <u>Sensors and Actuators B. 5</u> (Elsevier Sequoia - 1991), pp. 139-144

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Examiner Initial		Document Number	Date	Name	Class	Sub- Class	Filing Date If Appropriate
	AA						
	AB						
	AC						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub- Class	Translation
							Yes No
	AD						

OTHER DOCUMENTS

AE	Urban, G. et al., "Miniaturized multi-enzyme biosensors integrated with pH sensors on flexible polymer carriers for in vivo applications", <u>Biosensors & Bioelectronics</u> 7 (Elsevier Science Publishers Ltd. - 1992), pp. 733-739
AF	"3M Specifications and Design Guidelines, Microflex circuits for IC Interconnect Solutions," pages 1-32 (the entire document), 1997 (3M Electronic Products Division, Austin TX)
AG	"3M Offers More Solutions for the Semiconductor Industry" the entire document, 1997 (3M Electronic Products Division, Austin TX)
AH	"Microflex Solutions from 3M", the entire document, 1996 (3M Electronic Products Division, Austin TX)
AI	"Micron Wide Conductors and Spaces on ... PZT, Alumina, Glass and Flexible Materials" 1 page, no date (Metrigraphics, Wilmington, MA)
AJ	"Flexible circuits at Extreme Density", 8 unnumbered pages of various dates (Metrigraphics, Wilmington, MA)
AK	"Metrigraphics Ion Beam Etching Capability", 1 page, no date (Metrigraphics, Wilmington, MA)

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